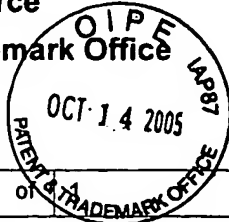




<b>FORM PTO 1449 US Department of Commerce</b> <b>Patent and Trademark Office</b> 		Application Number	10/038,745	
		Filing Date	01/02/2002	
		First Named Inventor	Robert Jackson	
		Group Art Unit	1754	
		Examiner Name	Nguyen, Ngoc Yen M.	
Sheet 1	of 1	Atty Docket Number	FOC1100-1	
Examiner Initials	Cite No.	<b>OTHER PRIOR ART – NON PATENT LITERATURE DOCUMENTS</b>		Date
<i>ryu</i>	<b>C17</b>	Mickelson, et al., "Fluorination of Single-Wall Carbon Nanotubes," <i>Chemical Physics Letters</i> 296," pgs. 188-194.		10/30/1998
<i> </i>	<b>C18</b>	Foon and Kaufman, Kinetics of Gaseous Fluorine Reactions, <i>Progress in Reaction Kinetics</i> , Vol. 8, No. 2, pp. 81-93		1975
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Examiner Signature	<i>Ngoc-yen Nguyen</i>		Date Considered	<i>1/6/06</i>